SAU 2811

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In remphration of:

فحيية المرسوة

MARK I. GARDNER MARK C. GILMER

Serial No.: 09/079,759

Filed: May 15, 1998

For: METHOD OF MAKING AN

ADVANCED ISOLATION

STRUCTURE FOR HIGH DENSITY SEMICONDUCTOR DEVICES

(as amended)

Examiner: W. Mintel

Group Art Unit: 2811

Att'y Docket: 2000.002600/TT2587

GROUP 2100

RESPONSE TO RESTRICTION REQUIREMENT DATED AUGUST 6, 1998

§

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as "FIRST CLASS MAIL" addressed to: Assistant Commissioner for Patents, Washington, DC 20231, this 30th day of September, 1998.

Signature

This paper is submitted in response to the Restriction Requirement dated August 6, 1998 for which the date for response was September 6, 1998.

In response to the restriction requirement which the Examiner imposed, Applicants elect, without traverse, to prosecute claims 20-28, *i.e.*, the Group II claims.

Additionally, please amend the title of the above-referenced application to read as follows:

-- METHOD OF MAKING AN ADVANCED ISOLATION STRUCTURE FOR HIGH DENSITY SEMICONDUCTOR DEVICES ---

A request for a one month extension of time to respond is included herewith along with the required fee. This one month extension will bring the due date to October 6, 1998, which is within the six-month statutory period.

The Examiner is invited to contact the undersigned attorney at (713) 934-4055 with any questions, comments or suggestions relating to the referenced patent application.

Respectfully submitted,

Date: September 30, 1998

لوسة الشداء

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